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Inventor(s)

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Methods and systems for performing on-the-fly automatic calibration adjustments of X-ray inspection systems

Abstract

The specification discloses methods of adjusting calibration data in an X-ray inspection system. Calibration data is initially generated. X-ray scan images of a cargo container are then acquired. Each of the X-ray scan images are segmented into regions of interest, where the regions of interest volumetrically encompass a known material or a material corresponding to a known HS code. Using the calibration data, first data indicative of Zeff of each of the regions of interest are determined. The first data is compared with second data indicative of known Zeff corresponding to the known materials and/or HS codes. The calibration data is then adjusted to generate a second calibration data if the first and second data differ significantly. The calibration data is replaced by the second calibration data in the memory.

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8442186	12/2012	Rothschild	N/A	N/A
8451974	12/2012	Morton	N/A	N/A
8457274	12/2012	Arodzero	N/A	N/A
8502699	12/2012	Zerwekh	N/A	N/A
8503605	12/2012	Morton	N/A	N/A
8503606	12/2012	Rothschild	N/A	N/A
8532823	12/2012	Mcelroy	N/A	N/A
8552722	12/2012	Lionheart	N/A	N/A
8559592	12/2012	Betcke	N/A	N/A
8625735	12/2013	Morton	N/A	N/A
8633823	12/2013	Armistead, Jr.	N/A	N/A
8690427	12/2013	Mastronardi	N/A	N/A
8750452	12/2013	Kaval	N/A	N/A
8766764	12/2013	Rayner	N/A	N/A
8774362	12/2013	Hughes	N/A	N/A
8804899	12/2013	Morton	N/A	N/A
8817098	12/2013	Millar	N/A	N/A
8824632	12/2013	Mastronardi Martan	N/A	N/A
8824637	12/2013 12/2013	Morton Morton	N/A	N/A N/A
8831176 8837669	12/2013	Morton	N/A N/A	N/A N/A
8842808	12/2013	Rothschild	N/A N/A	N/A N/A
8861684	12/2013	Al-Kofahi	N/A N/A	N/A N/A
8884236	12/2013	Rothschild	N/A N/A	N/A N/A
000 4 230	14/4013	Nouisciiilu	1 N / <i>L</i> 1	1 V/ / A

8885794	12/2013	Morton	N/A	N/A
8903045	12/2013	Schubert	N/A	N/A
8903046	12/2013	Morton	N/A	N/A
8908831	12/2013	Bendahan	N/A	N/A
8923481	12/2013	Schubert	N/A	N/A
8929509	12/2014	Morton	N/A	N/A
8958526	12/2014	Morton	N/A	N/A
8971484	12/2014	Beckmann	N/A	N/A
8971487	12/2014	Mastronardi	N/A	N/A
8993970	12/2014	Morton	N/A	N/A
9001973	12/2014	Morton	N/A	N/A
9014339	12/2014	Grodzins	N/A	N/A
9020095	12/2014	Morton	N/A	N/A
9020103	12/2014	Grodzins	N/A	N/A
9046465	12/2014	Thompson	N/A	N/A
9048061	12/2014	Morton	N/A	N/A
9052271	12/2014	Grodzins	N/A	N/A
9057679	12/2014	Morton	N/A	N/A
9086497	12/2014	Bendahan	N/A	N/A
9093187	12/2014	Johnson	N/A	N/A
9093245	12/2014	Morton	N/A	N/A
9099279	12/2014	Rommel	N/A	N/A
9111331	12/2014	Parikh	N/A	N/A
9113839	12/2014	Morton	N/A	N/A
9117564	12/2014	Rommel	N/A	N/A
9146201	12/2014	Schubert	N/A	N/A
9158030	12/2014	Morton	N/A	N/A
9183647	12/2014	Morton	N/A	N/A
9189846	12/2014	Axel	N/A	N/A
9208988	12/2014	Morton	N/A	N/A
9218933	12/2014	Langeveld	N/A	N/A
9223050	12/2014	Kaval	N/A	N/A
9257208	12/2015	Rommel	N/A	N/A
9263225	12/2015	Morton	N/A	N/A
9274065	12/2015	Morton	N/A	N/A
9282258	12/2015	Kuznetsov	N/A	N/A
9285488	12/2015	Arodzero	N/A	N/A
9291582	12/2015	Grodzins	N/A	N/A
9311277	12/2015	Rinkel	N/A	N/A
9417060	12/2015	Schubert	N/A	N/A
9420677	12/2015	Morton	N/A	N/A
9442082 9442213	12/2015	Morton Bendahan	N/A	N/A N/A
9465135	12/2015 12/2015	Morton	N/A N/A	N/A N/A
		Rommel		
9466456 9535019	12/2015 12/2016	Rothschild	N/A N/A	N/A N/A
9535019	12/2016	Arodzero	N/A N/A	N/A N/A
9562866	12/2016	Morton	N/A N/A	N/A N/A
9562986	12/2016	Peyton	N/A N/A	N/A N/A
9576766	12/2016	Morton	N/A N/A	N/A N/A
33/0/00	14/4010	TATOLIOII	1 N / / 1	1 V/ / A

9606259	12/2016	Morton	N/A	N/A
9618648	12/2016	Morton	N/A	N/A
9632205	12/2016	Morton	N/A	N/A
9632206	12/2016	Parikh	N/A	N/A
9638646	12/2016	Morton	N/A	N/A
9658343	12/2016	Arodzero	N/A	N/A
9675306	12/2016	Morton	N/A	N/A
9714920	12/2016	Lionheart	N/A	N/A
9726619	12/2016	Thompson	N/A	N/A
9747705	12/2016	Morton	N/A	N/A
9772426	12/2016	Armistead, Jr.	N/A	N/A
9823201	12/2016	Morton	N/A	N/A
9823383	12/2016	Hanley	N/A	N/A
9864076	12/2017	Stein	N/A	N/A
9867271	12/2017	Saverskiy	N/A	N/A
9891314	12/2017	Morton	N/A	N/A
9989508	12/2017	Awad	N/A	N/A
9996890	12/2017	Cinnamon	N/A	N/A
10021350	12/2017	Rayner	N/A	N/A
10048393	12/2017	Stein	N/A	N/A
10061041	12/2017	Rowland	N/A	N/A
10089956	12/2017	Awad	N/A	N/A
10107783	12/2017	Lionheart	N/A	N/A
10175381	12/2018	Morton	N/A	N/A
10210631	12/2018	Cinnamon	N/A	N/A
10228487	12/2018	Mastronardi	N/A	N/A
10254436	12/2018	Awad	N/A	N/A
10295483	12/2018	Morton	N/A	N/A
10302807	12/2018	Yu	N/A	N/A
10345479	12/2018	Langeveld	N/A	N/A
10353109	12/2018	Hanley	N/A	N/A
10366293	12/2018	Faviero	N/A	N/A
10368428	12/2018	Saverskiy	N/A	N/A
10386532	12/2018	Morton	N/A	N/A
10408967	12/2018	Morton	N/A	N/A
10422919	12/2018	Parikh	N/A	N/A
10452959	12/2018	Gautam	N/A	N/A
10453223	12/2018	Cinnamon	N/A	N/A
10504261	12/2018	Cinnamon	N/A	N/A
10509142	12/2018	Parikh	N/A	N/A
10510319	12/2018	Awad	N/A	N/A
10520612	12/2018	Stein	N/A	N/A
10527742	12/2019	Stein	N/A	N/A
10572963	12/2019	Cinnamon	N/A	N/A
10585206	12/2019	Bendahan	N/A	N/A
10593099	12/2019	Sudarsky	N/A	N/A
10598812	12/2019	Franco	N/A	N/A N/A
10650783	12/2019	Awad Morton	N/A	
10698128 10706335	12/2019 12/2019	Morton	N/A N/A	N/A N/A
10/00222	12/2019	Gautam	1 N / <i>F</i> 1	1 N / <i>F</i> 1

10770195	10768338	12/2019	Yu	N/A	N/A
10782440					
10795047					
10795048 12/2019 St-Aubin N/A N/A 10795049 12/2019 St-Aubin N/A N/A N/A 10809414 12/2019 St-Aubin N/A N/A 10809414 12/2019 Parikh N/A N/A 10930920 12/2019 Parikh N/A N/A 10901114 12/2020 St-Aubin N/A N/A 10942291 12/2020 Morton N/A N/A 10967271 12/2020 Morton N/A N/A 11010605 12/2020 Nord N/A N/A 11019024 12/2020 Parikh N/A N/A 11019245 12/2020 Parikh N/A N/A 11193898 12/2020 Stein N/A N/A 11193898 12/2020 Schubert N/A N/A 11263499 12/2021 Gautam N/A N/A 11280898 12/2021 Ginnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11443592 12/2021 Morton N/A N/A 11443577 12/2021 Stein N/A N/A 11443777 12/2021 Stein N/A N/A 11463121 12/2022 Morton N/A N/A 1148777 12/2021 Stein N/A N/A N/A 1148777 12/2021 Stein N/A N/A N/A 11561321 12/2022 Morton N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11822041 12/2022 Morton N/A N/A 1182041 12/2022 Morton N/A N/A 1182041 12/2022 Morton N/A N/A 1182041 12/2022 Morton N/A N/A 1197037 12/2023 Sit-Aubin N/A N/A 1197037 12/2023 Sit-Aubin N/A N/A 12169264 12/2023 Sivakumar N/A N/A 12169264 12/2023 Parikh N/A N/A 12169264 12/2023 Parikh N/A N/A 12169264 12/2023 Sivakumar N/A N/A 12169264 12/2023 Sivakumar N/A N/A 12169264 12/2023 Morton N/A N/A 12169264 12/2023 Morton N/A N/A 12169264 12/2023 Morton N/A N/A N/A 12169264 12/2023 Morton N/A N/A N/A 12169264 12/2023 Morton N/A N/A N/A 121692664 12/2023 Morton N/A N/A N/A 12169266 12/2004 Morton N/A N/A N/A			<u> </u>		
10795049					
10809414 12/2019	10795049	12/2019		N/A	N/A
10830920 12/2019 Parikh N/A N/A 10901114 12/2020 St-Aubin N/A N/A 10942291 12/2020 Morton N/A N/A 10976271 12/2020 Morton N/A N/A 11010605 12/2020 Parikh N/A N/A 11109245 12/2020 Barikh N/A N/A 11119345 12/2020 Stein N/A N/A 11193898 12/2020 Schubert N/A N/A 11276213 12/2021 Gautam N/A N/A 11287391 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 114287391 12/2021 Yu N/A N/A 114287391 12/2021 Yu N/A N/A 114287391 12/2021 Yu N/A N/A 11428777 12/2021 Stein N/A N/A	10809414			N/A	
10901114	10830920	12/2019		N/A	
10976271 12/2020 Morton N/A N/A 1109605 12/2020 Nord N/A N/A 11099294 12/2020 Parikh N/A N/A N/A 11109245 12/2020 Stein N/A N/A N/A 11163076 12/2020 Stein N/A N/A N/A 11163076 12/2020 Stein N/A N/A N/A 1128398 12/2020 Schubert N/A N/A N/A 11263499 12/2021 Gautam N/A N/A N/A 11280898 12/2021 Morton N/A N/A N/A 11280898 12/2021 Morton N/A N/A N/A 11287391 12/2021 Yu N/A N/A N/A 11487391 12/2021 Morton N/A N/A N/A 11448777 12/2021 Stein N/A N/A N/A 11448777 12/2021 Stein N/A N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11822041 12/2022 Sivakumar N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 118485752 12/2023 St-Aubin N/A N/A 11914085 12/2023 St-Aubin N/A N/A 1197035 12/2023 St-Aubin N/A N/A 12019035 12/2023 Sivakumar N/A N/A 12019035 12/2023 Archambault N/A N/A 12169264 12/2023 Morton N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Morton N/A N/A 12181619 12/2023 Stein N/A N/A 12235226 12/2000 Mazess N/A N/A 2003/0008556 12/2000 Adams N/A N/A 2003	10901114	12/2020	St-Aubin	N/A	N/A
11010605	10942291	12/2020	Morton	N/A	N/A
11099294 12/2020	10976271	12/2020	Morton	N/A	N/A
11119245 12/2020 Morton N/A N/A 11163076 12/2020 Stein N/A N/A 11193898 12/2020 Schubert N/A N/A 11263499 12/2021 Gautam N/A N/A 11276213 12/2021 Ginnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Morton N/A N/A 11423592 12/2021 Morton N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Morton N/A N/A 11822041 12/2022 Morton N/A N/A 11822041 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11914085 12/2023 Ritter N/A N/A	11010605	12/2020	Nord	N/A	N/A
11163076 12/2020 Stein N/A N/A 11193898 12/2020 Schubert N/A N/A 11263499 12/2021 Gautam N/A N/A 11276213 12/2021 Cinnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11307325 12/2021 Ginnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11448777 12/2022 Morton N/A N/A 11594001 12/2022 Morton N/A N/A 11790575 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11914085 12/2023 St-Aubin N/A N/A 11977037 12/2023 Ritter N/A N/A	11099294	12/2020	Parikh	N/A	N/A
11193898 12/2020 Schubert N/A N/A 11263499 12/2021 Gautam N/A N/A 11276213 12/2021 Cinnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11307325 12/2021 Morton N/A N/A 11448777 12/2021 Stein N/A N/A 115494001 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Morton N/A N/A 11822041 12/2022 Morton N/A N/A 11855775 12/2022 Morton N/A N/A 11914085 12/20223 St-Aubin N/A N/A 11977037 12/2023 Ritter N/A N/A 120935 12/2023 Archambault N/A N/A <	11119245	12/2020	Morton	N/A	N/A
11263499 12/2021 Gautam N/A N/A 11276213 12/2021 Cinnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11307325 12/2021 Morton N/A N/A 11423592 12/2021 Stein N/A N/A 1148777 12/2021 Stein N/A N/A 11594001 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Morton N/A N/A 11852041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11855752 12/2023 St-Aubin N/A N/A 1197037 12/2023 Ritter N/A N/A 12019035 12/2023 Riter N/A N/A <t< td=""><td>11163076</td><td>12/2020</td><td>Stein</td><td>N/A</td><td>N/A</td></t<>	11163076	12/2020	Stein	N/A	N/A
11276213 12/2021 Cinnamon N/A N/A 11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11307325 12/2021 Morton N/A N/A 11423592 12/2021 Cinnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Morton N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 1194085 12/2023 St-Aubin N/A N/A 11977037 12/2023 Ritter N/A N/A 12019035 12/2023 Archambault N/A N/A 12174334 12/2023 Morton N/A N/A </td <td>11193898</td> <td>12/2020</td> <td>Schubert</td> <td>N/A</td> <td>N/A</td>	11193898	12/2020	Schubert	N/A	N/A
11280898 12/2021 Morton N/A N/A 11287391 12/2021 Yu N/A N/A 11307325 12/2021 Morton N/A N/A 11423592 12/2021 Cinnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11885775 12/2023 St-Aubin N/A N/A 1194085 12/2023 Ritter N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12019035 12/2023 Archambault N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Manalad N/A N/A	11263499	12/2021	Gautam	N/A	N/A
11287391 12/2021 Yu N/A N/A 11307325 12/2021 Morton N/A N/A 11423592 12/2021 Cinnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 118455752 12/2023 St-Aubin N/A N/A 1194085 12/2023 Ritter N/A N/A 11977037 12/2023 Archambault N/A N/A 12019035 12/2023 Archambault N/A N/A 12169264 12/2023 Parikh N/A N/A 12181422 12/2023 Riter N/A N/A	11276213	12/2021	Cinnamon	N/A	N/A
11307325 12/2021 Morton N/A N/A 11423592 12/2021 Cinnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11914085 12/2023 Ritter N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12056840 12/2023 Archambault N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Manalad N/A N/A 12181619 12/2023 Manalad N/A <	11280898	12/2021	Morton	N/A	N/A
11423592 12/2021 Cinnamon N/A N/A 11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 1184085 12/2023 St-Aubin N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12019035 12/2023 Archambault N/A N/A 12169264 12/2023 Morton N/A N/A 12174334 12/2023 Parikh N/A N/A 12181422 12/2023 Manalad N/A N/A 12235226 12/2023 Morton N/A N/A 12235226 12/2002 Adams N/A	11287391	12/2021	Yu	N/A	N/A
11448777 12/2021 Stein N/A N/A 11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 1194085 12/2023 St-Aubin N/A N/A 11977037 12/2023 Ritter N/A N/A 12019035 12/2023 Archambault N/A N/A 12056840 12/2023 Morton N/A N/A 12169264 12/2023 Parikh N/A N/A 12181422 12/2023 Manalad N/A N/A 12285226 12/2023 Stein N/A N/A 2001/0016028 12/2002 Adams N/A N/A 2001/0022830 12/2000 Adams N/A N/A <td>11307325</td> <td>12/2021</td> <td>Morton</td> <td>N/A</td> <td>N/A</td>	11307325	12/2021	Morton	N/A	N/A
11561321 12/2022 Morton N/A N/A 11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11977037 12/2023 Ritter N/A N/A 12019035 12/2023 Archambault N/A N/A 12056840 12/2023 Morton N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Parikh N/A N/A 12181619 12/2023 Stein N/A N/A 12235226 12/2024 Morton N/A N/A 2001/0016028 12/2000 Adams N/A N/A 2001/0053202 12/2000 Mazess N/A N/A </td <td>11423592</td> <td>12/2021</td> <td>Cinnamon</td> <td>N/A</td> <td>N/A</td>	11423592	12/2021	Cinnamon	N/A	N/A
11594001 12/2022 Sivakumar N/A N/A 11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11914085 12/2023 Ritter N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12019035 12/2023 Archambault N/A N/A 12056840 12/2023 Morton N/A N/A 12169264 12/2023 Parikh N/A N/A 12181422 12/2023 Manalad N/A N/A 12181619 12/2023 Stein N/A N/A 12235226 12/2024 Morton N/A N/A 2001/0016028 12/2000 Adams N/A N/A 2001/0022830 12/2000 Sommer N/A	11448777	12/2021	Stein	N/A	N/A
11790575 12/2022 Cinnamon N/A N/A 11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11914085 12/2023 Ritter N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12019035 12/2023 Archambault N/A N/A 12056840 12/2023 Morton N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Parikh N/A N/A 12181422 12/2023 Manalad N/A N/A 12235226 12/2023 Stein N/A N/A 12235226 12/2024 Morton N/A N/A 2001/0022830 12/2000 Adams N/A N/A 2001/005302 12/2000 Mazess N/A <	11561321	12/2022	Morton	N/A	N/A
11822041 12/2022 Morton N/A N/A 11852775 12/2022 Morton N/A N/A 11885752 12/2023 St-Aubin N/A N/A 11914085 12/2023 Ritter N/A N/A 11977037 12/2023 Desjeans-Gauthier N/A N/A 12019035 12/2023 Archambault N/A N/A 12056840 12/2023 Sivakumar N/A N/A 12169264 12/2023 Morton N/A N/A 12181422 12/2023 Parikh N/A N/A 12181619 12/2023 Stein N/A N/A 12235226 12/2024 Morton N/A N/A 2001/0016028 12/2000 Adams N/A N/A 2001/0022830 12/2000 Sommer N/A N/A 2002/0063783 12/2001 Kurase N/A N/A 2003/008557 12/2002 Townzen N/A N/A 2003/0095626 12/2002 Anderton N/A	11594001	12/2022	Sivakumar	N/A	N/A
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2008/0298546	12/2007	Bueno	N/A	N/A
2008/0304622	12/2007	Morton	N/A	N/A
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2009/0010386	12/2008	Peschmann	N/A	N/A
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2009/0086907	12/2008	Smith	N/A	N/A
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2017/0358380	12/2016	Rothschild	N/A	N/A
2018/0038988	12/2017	Morton	N/A	N/A
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Background/Summary

CROSS-REFERENCE (1) The present application relies on U.S. Patent Provisional Application No. 63/369,386, titled "Methods and Systems for Performing On-The-Fly Automatic Calibration Adjustments of X-Ray Inspection Systems", and filed on Jul. 26, 2022, for priority, which is herein incorporated by reference in its entirety.

FIELD

- (1) The present specification is related generally to the field of X-ray inspection. More specifically, the present specification is related to a method of enabling automatic adjustment of calibration data of X-ray inspection systems while scanning an object under examination or inspection.

 BACKGROUND
- (2) Most modern high energy (2.5-9 MeV) transmission X-ray non-intrusive inspection systems offer some degree of cargo composition estimation by using interlaced dual energy pulses. By comparing the radiographic images of the low energy (3-5 MeV) and high energy (6-9 MeV) of the same container, different regions inside it can be characterized into four broad categories of materials: organic, inorganic (such as soil, fertilizer, salts, aluminum), metallic (such as steel, scrap

- metal), and High-Z materials (such as materials having an atomic number at or above tungsten).
- (3) Unlike the low energy inspection systems used for parcel and luggage screening where the prevailing process is the photoelectric effect, at high energies, the Compton effect dominates the interaction of X-rays with matter. The Compton process is weakly dependent on the effective atomic number of the material, making an accurate assessment difficult.
- (4) In addition to the challenges brought by physics, there are other challenges specific to the cargo screening such as, but not limited to: a) cargo clutter, where multiple optically dense objects overlap in the image; b) X-ray source stability (in terms of maintaining a consistent and/or predictable value for dose and energy) and detector stability, both of which may lead to calibration drift; c) energy-dependent X-ray scatter, where low and high energy beams produce different blur in the image and d) obscured objects of interest (such as high-Z shielding, weapons, or smuggled drug packages), which are often small compared to the rest of the imaged cargo.
- (5) Dual energy material separation methods involve a calibration process in which a set of materials with known atomic numbers and densities such as plastic, aluminum, steel, lead, tungsten, with different thicknesses are placed between the source and detectors, a scan is performed and responses of detectors for the high and low energy beam components are recorded. In normal operation mode, the inverse process takes place. Detectors record the high and low energy response to objects in the beam, and then algorithms determine the closest candidate, based on an effective atomic number (Zeff), in terms of material type and thickness. An uncertainty is associated with the determination of the material type, depending on the system geometry, X-ray flux and energies, and the number of samples (pulse pairs) used to make the determination.
- (6) Unfortunately, materials separation calibration does not remain stable over the lifetime of an X-ray inspection system. Changes often appear that make the Zeff calculation unreliable. In some conditions, the drift may even happen between two scans taken minutes apart.
- (7) Therefore, there is a need for a method that enables automatic modulation of calibration data for an X-ray system during scanning of an object under examination or inspection. SUMMARY
- (8) The following embodiments and aspects thereof are described and illustrated in conjunction with systems, tools and methods, which are meant to be exemplary and illustrative, and not limiting in scope. The present application discloses numerous embodiments.
- (9) In some embodiments, the present specification discloses a method of performing an on-the-fly adjustment of calibration data corresponding to an X-ray inspection system that comprises an X-ray source in data communication with a computing device, the method being implemented in the computing device having one or more physical processors programmed with a plurality of program instructions that, when executed by the one or more physical processors, cause the computing device to perform the method, the method comprising: generating, by the X-ray inspection system, a first plurality of calibration data, wherein the first plurality of calibration data is stored in a memory associated with the computing device; generating, using the X-ray inspection system, data representative of X-ray scan images of a cargo container; segmenting data representative of X-ray scan images into a plurality of regions of interest, wherein at least some of the plurality of regions of interest contain only one type of material having at least one of a known effective atomic number (Zeff) or a known HS code; determining, using the first plurality of calibration data, first data indicative of Zeff of the at least some of the plurality of regions of interest; comparing the first data with second data indicative of Zeff corresponding to the known Zeff or known HS code; adjusting the first plurality of calibration data to generate a second plurality of calibration data if the first and second data differ more than a predefined threshold; and using the second plurality of calibration data to process the data representative of X-ray scan images to generate and display Xray scan images.
- (10) Optionally, the method further comprises calculating a Zeff value for each pixel in the X-ray scan images; applying a smoothing algorithm to the Zeff values of multiple pixels, associated with

each of the plurality of regions of interest, in order to generate smoothed Zeff-based regions of interest; applying a predefined color map to the smoothed Zeff-based regions of interest; and displaying the color-coded X-ray scan images.

- (11) Optionally, the Zeff value for each pixel is calculated using the second plurality of calibration data if the first and second data differ more than the predefined threshold, and wherein the Zeff value for each pixel is calculated using the first plurality of calibration data if the first and second data do not differ more than the predefined threshold.
- (12) Optionally, the smoothing algorithm includes any one of simple running averages, shape preserving smoothing filters, image-guided segmentation or K-means clustering.
- (13) Optionally, the at least some of the plurality of regions of interest correspond to empty or unobstructed regions of the cargo container.
- (14) Optionally, the at least some of the plurality of regions of interest correspond to at least one of a volume encompassing only a top surface of the cargo container, a volume encompassing only a front end of the cargo container, or a volume encompassing only a rear end of the cargo container.

 (15) Optionally, the first plurality of calibration data is generated by: placing, between a radiation
- (15) Optionally, the first plurality of calibration data is generated by: placing, between a radiation source and detectors of the X-ray inspection system, a set of materials with known atomic numbers and densities, wherein the set of materials have different thicknesses; and recording responses of the detectors for each of the set of materials.
- (16) Optionally, the X-ray scan images correspond to low and high energies of the radiation source.
- (17) In some embodiments, the present specification is directed towards an X-ray inspection system comprising: a radiation source; an array of detectors; a computing device in data communication with the radiation source and the array of detectors, wherein the computing device has one or more physical processors programmed with a plurality of program instructions that, when executed by the one or more physical processors, cause the computing device to generate, using the X-ray inspection system, a first plurality of calibration data, wherein the first plurality of calibration data are stored in a memory associated with the computing device; generate, using the X-ray inspection system, X-ray scan images of a cargo container; segment the X-ray scan images into a plurality of regions of interest, wherein each of the plurality of regions of interest contain a single type of a material associated with a known atomic number or a single type of a material associated with a known HS code; determine, using the first plurality of calibration data, first data indicative of a first effective atomic number of the single type of the material associated with the known atomic number or a second effective atomic number of the single type of the material associated with the known HS code for each of the plurality of regions of interest; compare the first data with second data indicative of a known effective atomic number corresponding to the material associated with the known atomic number or a known effective atomic number corresponding to the material associated with the known HS code; adjust the first plurality of calibration data to generate a second plurality of calibration data if the first and second data differ significantly; and replace the first plurality of calibration data by the second plurality of calibration data in the memory. (18) Optionally, the plurality of program instructions, when executed by the one or more physical
- processors, further cause the computing device to: calculate an effective atomic number value for each pixel in the X-ray scan images; apply a smoothing algorithm to the effective atomic number values of multiple pixels, associated with each of the plurality of regions of interest, in order to generate smoothed effective atomic number-based regions of interest; apply a predefined color map to the smoothed effective atomic number-based regions of interest; and display the color coded X-ray scan images.
- (19) Optionally, the effective atomic number value for each pixel is calculated using the second plurality of calibration data if the first and second data differ significantly, and wherein the effective atomic number value for each pixel is calculated using the first plurality of calibration data if the first and second data do not differ significantly.
- (20) Optionally, the smoothing algorithm includes any one of simple running averages, shape

preserving smoothing filters, image-guided segmentation or K-means clustering.

- (21) Optionally, at least some of the plurality of regions of interest are empty or unobstructed.
- (22) Optionally, at least some of the plurality of regions of interest contain correspond to at least one of a volume encompassing only a top surface of the cargo container, a volume encompassing only a front end of the cargo container, or a volume encompassing only a rear end of the cargo container.
- (23) Optionally, the first plurality of calibration data is generated by: placing, between a radiation source and detectors of the X-ray inspection system, a set of materials with known atomic numbers and densities, wherein the set of materials have different thicknesses; and recording response of the detectors for each of the set of materials.
- (24) Optionally, the X-ray scan images correspond to low and high energies of the radiation source.
- (25) The aforementioned and other embodiments of the present specification shall be described in greater depth in the drawings and detailed description provided below.

Description

BRIEF DESCRIPTION OF THE DRAWINGS

- (1) The accompanying drawings illustrate various embodiments of systems, methods, and embodiments of various other aspects of the disclosure. Any person with ordinary skills in the art will appreciate that the illustrated element boundaries (e.g., boxes, groups of boxes, or other shapes) in the figures represent one example of the boundaries. It may be that in some examples one element may be designed as multiple elements or that multiple elements may be designed as one element. In some examples, an element shown as an internal component of one element may be implemented as an external component in another and vice versa. Furthermore, elements may not be drawn to scale. Non-limiting and non-exhaustive descriptions are described with reference to the following drawings. The components in the figures are not necessarily to scale, emphasis instead being placed upon illustrating principles.
- (2) FIG. **1** is a schematic drawing of an exemplary LINAC-based high-energy X-ray cargo inspection system that may implement a method described in the present specification in an embodiment;
- (3) FIG. **2**A shows segmented regions of a radiographic scan image of a cargo container, in accordance with some embodiments of the present specification;
- (4) FIG. **2**B shows a radiographic scan image of a container housing bananas, in accordance with some embodiments of the present specification; and
- (5) FIG. **3** is a flowchart of a plurality of exemplary steps of a method of processing X-ray scan images of an object under inspection for materials classification and on-the-fly automatic adaptive calibration, in accordance with some embodiments of the present specification.

DETAILED DESCRIPTION

(6) The present specification is directed towards multiple embodiments. The following disclosure is provided in order to enable a person having ordinary skill in the art to practice the invention. Language used in this specification should not be interpreted as a general disavowal of any one specific embodiment or used to limit the claims beyond the meaning of the terms used therein. The general principles defined herein may be applied to other embodiments and applications without departing from the spirit and scope of the invention. Also, the terminology and phraseology used is for the purpose of describing exemplary embodiments and should not be considered limiting. Thus, the present invention is to be accorded the widest scope encompassing numerous alternatives, modifications and equivalents consistent with the principles and features disclosed. For purpose of clarity, details relating to technical material that is known in the technical fields related to the invention have not been described in detail so as not to unnecessarily obscure the present invention.

- (7) In various embodiments, a computing device includes an input/output controller, at least one communications interface and system memory. The system memory includes at least one random access memory (RAM) and at least one read-only memory (ROM). These elements are in communication with a central processing unit (CPU) to enable operation of the computing device. In various embodiments, the computing device may be a conventional standalone computer or alternatively, the functions of the computing device may be distributed across multiple computer systems and architectures.
- (8) In some embodiments, execution of a plurality of sequences of programmatic instructions or code enable or cause the CPU of the computing device to perform various functions and processes. In alternate embodiments, hard-wired circuitry may be used in place of, or in combination with, software instructions for implementation of the processes of systems and methods described in this application. Thus, the systems and methods described are not limited to any specific combination of hardware and software.
- (9) In the description and claims of the application, each of the words "comprise", "include", "have", "contain", and forms thereof, are not necessarily limited to members in a list with which the words may be associated. Thus, they are intended to be equivalent in meaning and be openended in that an item or items following any one of these words is not meant to be an exhaustive listing of such item or items, or meant to be limited to only the listed item or items. It should be noted herein that any feature or component described in association with a specific embodiment may be used and implemented with any other embodiment unless clearly indicated otherwise.

 (10) It must also be noted that as used herein and in the appended claims, the singular forms "a," "an," and "the" include plural references unless the context dictates otherwise. Although any systems and methods similar or equivalent to those described herein can be used in the practice or testing of embodiments of the present disclosure, the preferred, systems and methods are now described.
- (11) "On-the-fly adjustment" refers to performing an adjustment to calibration data 1) immediately after a scan has occurred (first scan) and before an immediately subsequent scan is performed, 2) based on the scan data that was just acquired from the first scan, and 3) without manual or human intervention.

Overview

- (12) FIG. 1 illustrates an exemplary LINAC-based high-energy X-ray cargo inspection system that may be configured and used, in an embodiment, to implement the method(s) described in the present specification. As shown, the cargo inspection system 130 comprises a high-energy radiation source 105 for irradiating an object under inspection 110 with a vertically divergent fan beam of radiation 115. The high-energy radiation source 105 may be, but is not limited to, a linear accelerator (LINAC) or Betatron. In embodiments, the LINAC or any other source provides a radiation dose sufficient for imaging containers and cargo. In an embodiment, the energy and dose output of the LINAC or any other source ranges from 750 keV to 10 MeV and 0.07 Gy/min to 15 Gy/min, respectively.
- (13) The choice of source type, source intensity, and energy output depends upon the sensitivity of the detectors, the radiographic density of the cargo positioned in the space between the source and detectors, radiation safety considerations, and operational requirements, such as the inspection speed. One of ordinary skill in the art would appreciate the factors that need to be considered when selecting a radiation source type depend upon inspection requirements. In one embodiment, where the object under inspection **110** is a large-sized container or car that highly attenuates the X-ray beam, the radiation may be from an X-ray source operating at an energy ranging from approximately 750 keV and even up to 10 MeV or more. In various embodiments, the object under inspection **110** may be a vehicle, truck, rail car or other containers for carrying cargo, passenger luggage or general belongings.
- (14) The cargo inspection system 130 further comprises a detector array 120, which is preferably

positioned behind the object under inspection **110** and is configured to and used to detect radiation transmitted through the object under inspection **110**. The detectors **120**, in an embodiment, are formed by a stack of crystals that generate analog signals when X-rays impinge upon them, with the signal strength proportional to the amount of beam attenuation in the object under inspection **110**. In one embodiment, the X-ray beam detector arrangement consists of a linear array of solidstate detectors of the crystal-diode type. A typical arrangement uses cadmium tungstate scintillating crystals to absorb the X-rays transmitted through the object under inspection 110 and to convert the absorbed X-rays into photons of visible light. Crystals such as bismuth germinate, sodium iodide or other suitable crystals may be alternatively used as known to a person of ordinary skill in the art. The crystals can be directly coupled to a suitable detector, such as a photodiode or photo-multiplier. The detector photodiodes may be linearly arranged, which through unity-gain devices, provide advantages over photo-multipliers in terms of operating range, linearity and detector-to-detector matching. In another embodiment, an area detector is used as an alternative to linear array detectors. Such an area detector may be a scintillating strip, such as cesium iodide or other materials known in the art, viewed by a suitable camera or optically coupled to a charge-coupled device (CCD).

(15) It would be apparent to persons of skill in the art that the cargo inspection system **130** shown in FIG. **1** is just one example of an inspection system employing high-energy X-ray sources such as, but not limited to LINAC or Betatron. In some embodiments, the radiation source **105** uses interlaced dual energy pulses in order to generate X-ray scan images of low energy (3-5 MeV) and high energy (6-9 MeV) of the object under inspection **110**. Calibration Drift

- (16) The present specification recognizes that calibration data for materials separation does not remain stable over the lifetime of an X-ray inspection system. Changes in calibration, also referred to as "calibration drift" often appear and render the Zeff (effective atomic number) calculation unreliable for effective materials separation data. In some conditions, the drift may happen even between two scans taken minutes apart. The following sources, factors, causes or variables may all contribute to calibration drift. The X-ray source itself may be a contributing cause of calibration drift. Dose drift may be induced by beam current or beam energy changes. These include magnet changes (Betatron), automatic frequency control (AFC) shift, and wave guide temperature variation. Beam formation mechanics, which may include collimator alignment casting shadows, detector stack boom oscillations, detector collimator fins shift may also contribute to calibration drift. In addition, X-ray detectors may have problems with photodiode dark current and scintillator light yield, which contribute to calibration drift.
- (17) More than one cause of calibration shift may occur at the same time. However, only a few of the sources, factors, causes or variables of calibration drift have built-in mechanisms for compensation such as, for example, reference detectors and dark current measurement at the beginning of a scan or in-between pulses. These sources, factors, causes or variables of calibration drift are generally non-linear and are often linked with each other in complicated ways. Also, full recalibration is time consuming and is only a temporary solution for causes such as temperature excursions or slight magnetic drift (in a Betatron) or AFC drift (in a LINAC). Automatic Adaptive Calibration
- (18) In accordance with aspects of the present specification, instead of parametrizing the contribution of each source, factor, cause or variable to the calibration drift, a phenomenological model is developed in which the system is configured to check an accuracy of the Zeff calculation in almost every scan and in which the system is configured to automatically adjust the calibration data in order to improve scan data, and in particular, materials separation accuracy.
- (19) FIG. **2**A shows segmented regions of a radiographic scan image **200** of a cargo container **202**, in accordance with some embodiments of the present specification. In a non-limiting exemplary scenario, the image **200** has at least five regions or sections (also referred to as regions or sections

- of interest), that is, first region **205**, second region **207**, third region **209**, fourth region **211**, and fifth region **213** for which the material is conventionally known to be steel (for ISO containers, for example). Also, for the at least five regions **205**, **207**, **209**, **211**, **213** the attenuation and angular range (relative to a central axis of an X-ray beam used to scan the cargo container **202**) vary enough. In embodiments, the regions are selected for different purposes. For example, referring to FIG. **2A**, and by way of example only, regions **207**, **209**, and **211** are selected for stability since the variation is relatively small compared to regions **205** and **213**, which are selected to have large angular coverage and varying attenuations.
- (20) In embodiments, a radiographic scan image, such as the image **200** of the cargo container **202**, is segmented into one or more regions or sections of interest based on a variability of attenuation and an angular range relative to the central axis of the X-ray beam. In some embodiments, the one or more regions or sections of interest are selected such that the expected attenuation (of the regions or sections of interest) varies more than 10% and the angular range or span is greater than 2 degrees relative to the central axis of the X-ray beam.
- (21) Containers, such as the cargo container **202**, typically have one or more regions such as, for example, a front end (comprising first region 205) and a rear end (comprising fifth region 213) and a top portion (comprising second region **207**, third region **209**, and fourth region **211**) that remain unobstructed. It should be noted that the fifth region **213** and at least the second top region **207** are almost always unobstructed for most cargo containers. The first region or front end **205** is also unobstructed in most cases. The second region **207**, third region **209**, and fourth region **211** are illustrative non-limiting examples of areas or portions in the image **200** that are found to be unobstructed and that can be used for calibration adjustment. These regions will, however, differ on a case-by-case basis depending on how a container is loaded. In some embodiments, a bottom surface or portion 227 of the cargo container 202 may also be at least partially unobstructed (with known container material). Therefore, in various embodiments, an X-ray scan image of a container is analyzed and segmented to identify regions or areas for which material composition is known, wherein such regions or areas of known material composition include portions inside or within the container such as, but not limited to, unobstructed regions (that is, regions not loaded with cargo) of the container, and portions outside the container such as, but not limited to, tires, windshield, vehicle frame around axles and fuel or gas tank.
- (22) For example, in one embodiment, the region of interest comprising the top portion (comprising at least one of the second region **207**, third region **209**, and fourth region **211**) of the cargo container **202** is made of only the material that separates the internal volume of the cargo container **202** from the outside environment. In another embodiment, the material that separates the internal volume of the cargo container **202** from the outside environment makes up at least 20%, 30%, 40%, 50%, 60%, 70%, 80%, 90%, or any numerical increment between 20% and 90% of the region of interest comprising the top portion of the cargo container **202**.
- (23) In another example, in one embodiment, the region of interest comprising the front end (comprising first region **205**) of the cargo container **202** is made of only the material that separates the internal volume of the cargo container **202** from the outside environment. In another embodiment, the material that separates the internal volume of the cargo container **202** from the outside environment makes up at least 20%, 30%, 40%, 50%, 60%, 70%, 80%, 90%, or any numerical increment between 20% and 90% of the region of interest comprising the front end of the cargo container **202**.
- (24) In yet another example, in one embodiment, the region of interest comprising the rear end (comprising fifth region **213**) of the cargo container **202** is made of only the material that separates the internal volume of the cargo container **202** from the outside environment. In another embodiment, the material that separates the internal volume of the cargo container **202** from the outside environment makes up at least 20%, 30%, 40%, 50%, 60%, 70%, 80%, 90%, or any numerical increment between 20% and 90% of the region of interest comprising the rear end of the

cargo container **202**.

- (25) In still another example, in one embodiment, the region of interest comprising the bottom surface or portion **227** of the cargo container **202** is made of only the material that separates the internal volume of the cargo container **202** from the outside environment. In another embodiment, the material that separates the internal volume of the cargo container **202** from the outside environment makes up at least 20%, 30%, 40%, 50%, 60%, 70%, 80%, 90%, or any numerical increment between 20% and 90% of the region of interest comprising the bottom surface or portion of the cargo container **202**.
- (26) Also, the first region **205** and fifth region **213** are of interest because of the angular coverage or span of more than 15 degrees off the central axis of the X-ray beam. As known to persons of ordinary skill in the art, due to the physics of X-ray production, the shape of an attenuation curve is expected to change if the energy of the electrons producing the X-rays changes. High energy beams have flux and energy composition roll-off as a function of angle relative to the central axis of the X-ray beam. The roll-off function is different at 4 MeV versus 6 MeV. In some embodiments, the change, drift or modification of the calibration curves is determined by calculating the variation of the roll-off curves.
- (27) In accordance with some embodiments, the unobstructed regions, such as second region **207**, third region **209**, and fourth region **211**, are identified and used as data points. In some embodiments, machine learning techniques such as, but not limited to, mask R-CNNs (Region-based Convolutional Neural Networks) or U-Nets are configured to segment the image **200** for more features inside and outside the cargo container **202** suitable for use in automatic calibration adjustments.
- (28) In some embodiments, for scans that have the HS code associated with the X-ray image, the cargo inside the container is used to check and adjust, if required, the calibration data. For example, FIG. 2B shows a radiographic scan image 220 of a container 230 housing bananas, in accordance with some embodiments of the present specification. The dotted box 225 shows that the cargo segmentation algorithm successfully identified the cargo region 222 inside the refrigerated ISO container 230.
- (29) In accordance with various embodiments, there are multiple other sections or regions inside the container **230** that can be used to check and, if required, adjust the calibration data. The top edge region **235** of the container **230** is metallic and uncluttered, the back edge **240** of the container **230** is also metallic and spans a large angular range relative to a central axis of an X-ray beam used to scan the container **230**. Inside, the bananas **222** are organic with a large angular and attenuation coverage.
- (30) Thus, in embodiments, the present specification is directed towards a radiographic or X-ray image processing method of identifying or segmenting one or more regions or sections of interest of a cargo container for which the materials are known and that have associated large angular and attenuation coverage. In various embodiments, the one or more regions or sections of interest have an associated angular span of more than 2 degrees and an attenuation variation of more than 10% relative to the mean inside each of the one or more regions or sections of interest. Thus, in embodiments, this refers to particular values relative to the values within the region itself. As an non-limiting example, this may represent regions 205 and 213. Thereafter, the method computationally links the variation of Zeff values of the identified or segmented regions of interest relative to the current calibration and adjusts the parameters of the calibration curves to match with known materials.
- (31) In embodiments, the regions of interest may become obstructed by known features and materials, such as, for example, the skin of the cargo container. In order to be a region of interest, a condition is being able to determine (or having a way of knowing) what material is contained by the region of interest. This information is obtained either through the identification of known features (for example, cargo container parts, vehicle tires, windshield, etc.), HS codes, or other

- ways of identifying an object. For example, a machine learning algorithm may be configured to identify tires, ceramic tiles or engine blocks inside the cargo container as these are made of known materials.
- (32) FIG. **3** is a flowchart of a plurality of exemplary steps of a method **300** of processing X-ray scan images of an object under inspection for materials classification and on-the-fly automatic adaptive adjustment of calibration data, in accordance with some embodiments of the present specification. In embodiments, the method **300** comprises a plurality of programmatic instructions or code stored in a non-transient memory associated with a computing device that is in data communication with an X-ray inspection system configured to generate the X-ray scan images. The computing device includes a processor and random access memory, wherein the processor executes the method **300**.
- (33) In some embodiments, the X-ray inspection system is configured to use interlaced dual energy pulses in order to generate the X-ray scan images of low energy (3-5 MeV) and high energy (6-9 MeV) of the cargo container. In various embodiments, the object under inspection may be a vehicle, truck, rail car or other containers for carrying cargo, passenger luggage or general belongings. In a non-limiting exemplary scenario, the steps of the method **300** are being described with reference to a cargo container scanned using a dual-energy X-ray inspection system. Alternate embodiments may use a single-energy X-ray inspection system. Further, embodiments may use a multi-view X-ray inspection system having single or dual-energy capabilities.
- (34) At step **302**, as a result of an initial calibration process, the X-ray inspection system is configured to generate a first plurality of calibration data. The first plurality of calibration data is stored in the non-transient memory associated with the computing device. In the initial calibration process, a set of materials with known atomic numbers and densities such as plastic, aluminum, steel, lead, tungsten, with different thicknesses is put between the X-ray source and detectors (of the X-ray inspection system) and the response of the detectors, for the high and low energy beam components, is recorded corresponding to the first plurality of calibration data.
- (35) At step **304**, the X-ray inspection system is operated to scan a cargo container, thereby generating data indicative of dual-energy X-ray scan images. At step **306**, the computing device is configured to apply a cargo materials segmentation algorithm, known to persons of ordinary skill in the art, to the X-ray scan images in order to identify and segment first areas or regions of interest (ROI) with known materials composition (in some embodiments, the first areas or regions of interest contain only one type of material having a known effective atomic number (Zeff)). For example, for an ISO container, the first areas or regions of interest include top and ends (front and rear) that may be unobstructed and known to be of steel. The unobstructed areas or regions may also include those portions of the container that are empty or devoid of the presence of any cargo or goods. In further examples, the first areas or regions of interest may additionally include tires, the windshield, vehicle frame around axles and fuel tank.
- (36) It should be appreciated that calibration curves are non-linear. Although a single region or section of interest can be used for materials classification and on-the-fly automatic adaptive adjustment of calibration data, the greater the number of regions or sections of interest are processed, the more accurate the recalibration or adjustment of calibration data becomes.
- (37) At step **308**, the computing device is configured to determine if one or more HS (Harmonized Commodity Description and Coding System) codes, associated with the cargo or goods of the cargo container and therefore the X-ray scan images, are known. HS codes are identification codes given to goods for use in international trade. The HS codes are administered by the World Customs Organization (WCO) and are internationally accepted for use by customs authorities and companies to identify goods/cargo.
- (38) If the one or more HS codes are known, then at step **310**, the computing device is configured to further segment the cargo or goods regions of the X-ray scan images into one or more second areas or regions of interest corresponding to the one or more HS codes and subsequently the flow

- moves to step **312**. At step **312**, the computing device is configured to determine first data indicative of the Zeff of the segmented first and/or second regions of interest using the first plurality of calibration data.
- (39) If the one or more HS codes are not known, then the computing device is configured to determine first data indicative of the Zeff of the segmented first regions of interest using the first plurality of calibration data. The second regions of interest, which include known HS codes, are used to provide additional data points to the recalibration model. As described earlier, the segmented first regions of interest are those corresponding to known materials while the segmented second regions of interest are those corresponding to one or more HS codes. Thus, if the one or more HS codes are known, then the computing device is configured to determine first data indicative of the Zeff of the segmented first region of interest and segmented second region of interest using the first plurality of calibration data.
- (40) At step **314**, the computing device is configured to compare the first data with second data indicative of reference Zeff corresponding to the known materials and/or HS codes of the segmented first and/or second regions of interest. At step **316**, the computing device is configured to determine if the first data is significantly different or deviated from the second data. In some embodiments, the first data is considered to be significantly different or deviated from the second data if the first and second data differ or deviate by at least 2 atomic number units. In some embodiments, the first data is considered to be significantly different or deviated from the second data if the first and second data differ or deviate by at least 3 atomic number units.
- (41) If a significant difference or deviation is determined, as defined above, then at step **318**, the first plurality of calibration data is adjusted or modulated based on the second data in order to generate a second plurality of calibration data, the first plurality of calibration data is replaced by the second plurality of calibration data for storing in the memory, at step **320**, and subsequently the flow moves to step **322**.
- (42) It should be appreciated that the adjustment or modulation of the first plurality of calibration data is non-linear. The adjustment or modulation is dependent on the number of regions or sections of interest identified or available. In some embodiments, if the identified regions or sections of interest correspond only to container components then a shift in the calibration curves (of the first plurality of calibration data) is performed to recalibrate. However, if the regions or sections of interest with HS codes are also available then each calibration curve (in the first plurality of calibration data) corresponding to the specific type of material is modified or modulated.

 (43) At step 322, the computing device is configured to calculate a Zeff value for each individual
- pixel in the whole X-ray scan images. In embodiments, the Zeff value for each pixel is calculated using the second plurality of calibration data if the first and second data differ significantly, as defined above. However, the Zeff value for each pixel is calculated using the first plurality of calibration data if the first and second data do not differ significantly.
- (44) At step **324**, the computing device is configured to apply materials segmentation algorithm to the X-ray images in order to generate a plurality of segments and thereafter apply a smoothing or averaging filter or algorithm to the Zeff values (of step **322**) of multiple pixels, associated with each of the plurality of segments, in order to generate one or more smoothed Zeff-based segments, regions or clusters in the X-ray images. In various embodiments, the smoothing or averaging involves techniques such as, but not limited to, simple running averages to shape preserving smoothing filters, image-guided segmentation and K-means clustering.
- (45) Thereafter, at step **326**, the computing device is configured to apply a predefined color map or code to the one or more smoothed Zeff-based regions of interest, segments or clusters. For example, a smoothed Zeff-based segment corresponding to organic materials are colored orange, metallic materials are colored in blue, inorganic materials are colored in green and high-Z materials are colored in red. Segments or regions with unreliable Zeff due to too little attenuation or too much noise remain uncolored (grayscale).

- (46) Finally, at step **328**, the computing device is configured to render or display color-coded X-ray images on a display.
- (47) The above examples are merely illustrative of the many applications of the systems and methods of the present specification. Although only a few embodiments of the present invention have been described herein, it should be understood that the present invention might be embodied in many other specific forms without departing from the spirit or scope of the invention. Therefore, the present examples and embodiments are to be considered as illustrative and not restrictive, and the invention may be modified within the scope of the appended claims.

Claims

- 1. A method of performing an on-the-fly adjustment of calibration data corresponding to an X-ray inspection system that comprises an X-ray source in data communication with a computing device, the method being implemented in the computing device having one or more physical processors programmed with a plurality of program instructions that, when executed by the one or more physical processors, cause the computing device to perform the method, the method comprising: generating, by the X-ray inspection system, a first plurality of calibration data, wherein the first plurality of calibration data is stored in a memory in data communication with the computing device; generating, using the X-ray inspection system, data representative of X-ray scan image of a cargo container; segmenting data representative of the X-ray scan image into a plurality of regions of interest, wherein at least some of the plurality of regions of interest contain only one type of material having at least one of a known effective atomic number (Zeff) or a known identification code; determining, using the first plurality of calibration data, first data indicative of Zeff of the at least some of the plurality of regions of interest; comparing the first data with second data indicative of Zeff corresponding to the known Zeff or known identification code; adjusting the first plurality of calibration data to generate a second plurality of calibration data if the first data and the second data differ more than a predefined threshold; and using the second plurality of calibration data to process the data representative of the X-ray scan image to generate and display the processed X-ray scan image.
- 2. The method of claim 1, further comprising: calculating a Zeff value for each pixel in the X-ray scan image; applying a smoothing function to the Zeff values of multiple pixels, associated with each of the plurality of regions of interest, in order to generate smoothed Zeff-based regions of interest; applying a predefined color map to the smoothed Zeff-based regions of interest to generate a color-cded X-ray scan image; and displaying the color-coded X-ray scan image.
- 3. The method of claim 2, wherein the Zeff value for each pixel is calculated using the second plurality of calibration data if the first data and the second data differ more than the predefined threshold, and wherein the Zeff value for each pixel is calculated using the first plurality of calibration data if the first data and the second data do not differ more than the predefined threshold.
- 4. The method of claim 2, wherein the smoothing function comprises at least one a simple running average function, a shape preserving smoothing filter function, an image-guided segmentation function or K-means clustering function.
- 5. The method of claim 1, wherein the at least some of the plurality of regions of interest correspond to one or more empty regions of the cargo container or one or more unobstructed regions of the cargo container.
- 6. The method of claim 1, wherein at least one of the plurality of regions of interest corresponds to of a volume encompassing only a top surface of the cargo container, a volume encompassing only a front end of the cargo container.
- 7. The method of claim 1, wherein the first plurality of calibration data is generated by: placing, between a radiation source and detectors of the X-ray inspection system, a set of materials with

known atomic numbers and densities, wherein the set of materials have different thicknesses; and recording responses of the detectors for each material of the set of materials.

- 8. The method of claim 7, wherein the X-ray scan image represents recorded data corresponding to both low and high energies of the radiation source.
- 9. The method of claim 1, wherein at least one of the plurality of regions of interest corresponds to a volume encompassing only a front end of the cargo container.
- 10. The method of claim 1, wherein at least one of the plurality of regions of interest corresponds to a volume encompassing only a rear end of the cargo container.
- 11. An X-ray inspection system comprising: a radiation source; an array of detectors; a computing device in data communication with the radiation source and the array of detectors, wherein the computing device has one or more physical processors programmed with a plurality of program instructions that, when executed by the one or more physical processors, cause the computing device to: generate a first plurality of calibration data, wherein the first plurality of calibration data are stored in a memory associated with the computing device; generate, using data detected by the array of detectors, an X-ray scan image of a cargo container; segment the X-ray scan image into a plurality of regions of interest, wherein at least some of the plurality of regions of interest contain a single type of a material associated with a known atomic number or a single type of a material associated with a known identification code; determine, using the first plurality of calibration data, first data indicative of a first effective atomic number of the single type of the material associated with the known atomic number or a second effective atomic number of the single type of the material associated with the known identification code for at least some of the plurality of regions of interest; compare the first data with second data indicative of a known effective atomic number corresponding to the material associated with the known atomic number or a known effective atomic number corresponding to the material associated with the known identification code; adjust the first plurality of calibration data to generate a second plurality of calibration data if the first data and the second data differ more than a predefined amount; and replace the first plurality of calibration data by the second plurality of calibration data in the memory.
- 12. The X-ray inspection system of claim 9, wherein the plurality of program instructions, when executed by the one or more physical processors, further cause the computing device to: calculate an effective atomic number value for each pixel in the X-ray scan image; apply a smoothing functionalgorithm to the effective atomic number values of multiple pixels, associated with each the at least some of the plurality of regions of interest, in order to generate smoothed effective atomic number-based regions of interest; apply a predefined color map to the smoothed effective atomic number-based regions of interest to generate a color-coded X-ray scan image; and display the color-coded X-ray scan image.
- 13. The X-ray inspection system of claim 12, wherein the effective atomic number value for each pixel is calculated using the second plurality of calibration data if the first data and the second data differ more than the predefined amount, and wherein the effective atomic number value for each pixel is calculated using the first plurality of calibration data if the first data and the second data do not differ more than the predefined amount.
- 14. The X-ray inspection system of claim 12, wherein the smoothing function includes at least one of a simple running averages, shape preserving smoothing filter function, an image-guided segmentation function or a K-means clustering function.
- 15. The X-ray inspection system of claim 11, wherein at least some of the plurality of regions of interest are empty or unobstructed.
- 16. The X-ray inspection system of claim 9, wherein at least one of the plurality of regions of interest corresponds to a volume encompassing only a top surface of the cargo container.
- 17. The X-ray inspection system of claim 9, wherein the first plurality of calibration data is generated by: placing, between the radiation source and the array of detectors, set of materials with known atomic numbers and densities, wherein the set of materials have different thicknesses; and

recording a response of the array of detectors for each material in the set of materials.

- 18. The X-ray inspection system of claim 15, wherein the X-ray scan image comprises data representative low and high energies of the radiation source.
- 19. The X-ray inspection system of claim 11, wherein at least one of the plurality of regions of interest corresponds to a volume encompassing only a front end of the cargo container.
- 20. The X-ray inspection system of claim 11, wherein at least one of the plurality of regions of interest corresponds to a volume encompassing only a rear end of the cargo container.